

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	) Confirmation No. 2927
Osamu Nakamura	)
Application No. 10/807,472	) Examiner: Rakesh Kumar Dhingra
Filed: March 24, 2004	) Group Art Unit: 1763
For: PLASMA TREATMENT APPARATUS	)
	) Date: March 12, 2007

**AMENDMENT**

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 11, 2006, please amend the above-captioned application as follows: